

Form PTO-1449 U.S. Department of Commerce  
(Rev. 8-88) Patent and Trademark Office

Attorney Docket No.: 1201.70367

Serial No.: 10/829,486

INFORMATION DISCLOSURE CITATION  
(Use several sheets if necessary)

Applicant: Nayfeh et al.

Filing Date: April 22, 2004

Group: 1754

## U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate

## FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
						Abs.	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>mm</i>	Fujii, M., Hayashi, S., Yamamoto, K., "Photoluminescence from B-Doped Si Nanocrystals," Journal of Applied Physics, American Institute of Physics, New York, Vol. 83, No. 12, June 15, 1998, pp. 7953-7957.
<i>mm</i>	Levoska, J., Tyunina, M., Leppävuori, S., "Laser Ablation Deposition of Silicon Nanostructures," NanoStructured Materials, Elsevier, New York, Published Online October 6, 1999, pp. 101-106.
<i>mm</i>	Brus, L., "Luminescence of Silicon Nanocrystals and Porous Silicon," Japanese Journal of Applied Physics, Publication Office Japanese Journal of Applied Physics, Tokyo, JP, Vol. 34, No. 34-1, Suppl., January 1994, pp. 5-7.

Examiner

*Markel Medina*

Date Considered

*6/29/2005*

\*Examiner:

Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.